



Characteristics of entropy generation and heat transfer in double-layered micro heat sinks with complex structure



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ABSTRACT

A new type of double-layered micro heat sink (DL-MCHS) with complex structure is designed and investigated numerically. Moreover, a model of entropy generation rate of DL-MCHSs is also derived from the first and second laws of thermodynamics. Results for the relationship of entropy generation rate between the first and second layer of DL-MCHSs, total entropy generation rate, the average temperature on the bottom wall, thermal resistance and pressure drop are investigated in detail, respectively. The results indicate that the effect of entropy generation rate of the first layer on total entropy generation rate is dominant. The thermal characteristic of DL-MCHSs with complex structure is better than that of all DL-MCHSs and single-layered micro heat sinks (SL-MCHSs) with simple structure under the same volumetric flow rate. However, DL-MCHSs only show better thermodynamic advantage and thermal performance than SL-MCHSs with complex structure when the volumetric flow rate larger than a certain value. It is not reasonable to use DL-MCHSs for cooling microelectronic equipments under small volumetric flow rate due to the larger irreversibility. Finally, the pressure drop of DL-MCHSs can be reduced by properly changing the channel height under various volumetric flow rates. Due to the less irreversibility and more uniform temperature distribution on the bottom wall, DL-MCHSs can effectively eliminate the internal thermal stresses in microelectronic equipments. Therefore, DL-MCHSs are an alternative method for the electronic cooling. Moreover, the thermodynamic analysis provides references for the actual application design.

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1. Introduction

With the growing increment of integrated density and heat generation by the microelectronic equipment, the heat removal has become an important challenge for their thermal performance and lifespan. It is important to keep the peak temperature lower than the acceptable temperature levels [1–3]. The uniformity of temperature distribution is also helpful for the reliability and lifetime of microelectronic equipment. DL-MCHSs are an alternative method for cooling the microelectronics, due to its large heat transfer area to volume ratio and high-heat-flux removal ability compared to SL-MCHSs.

A DL-MCHS was firstly proposed by Vafai et al. [4], which was one atop the other with the coolant flow in the same or opposite direction in each layer. At the same time, the thermal performance with counter flow was studied numerically. They pointed out that both the temperature rise and pressure drop were substantially

lower than that in SL-MCHSs. Following their works, a considerable effort has been devoted to the study of the characteristic of the flow and heat transfer in such micro heat sinks [5–12].

Wei et al. [5] performed experimental and numerical works for coolant cooling in a stacked micro heat sink, and then found both the thermal resistance and pressure drop to be generally lower than that in SL-MCHSs. Levac et al. [6] conducted a comparison of the performance of DL-MCHSs between parallel flow and counter flow, respectively. They found that the thermal resistance of parallel flow was lower than that of counter flow at low Reynolds number, whereas counter arrangement was found to be superior in terms of the uniformity of the bottom temperature. Xie et al. [7] investigated the characteristic of flow and heat transfer in DL-MCHS. Their results showed that DL-MCHS not only reduced the pressure drop but also had better thermal performance compared with SL-MCHS under the same pumping power. Wu et al. [8] numerically conducted DL-MCHS with current flow under different geometrical parameters and flow conditions. They found that the overall performance increased by adjusting the inlet velocity of upper channels to

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